


<b>Search Notes</b> 	<b>Application No.</b>	<b>Applicant(s)</b>	
	10/605,326	YEH ET AL.	
	<b>Examiner</b>	<b>Art Unit</b>	
	Stephen W. Smoot	2813	

SEARCHED			
Class	Subclass	Date	Examiner
438	525	8/21/2004	SWS
438	528	8/21/2004	SWS
438	586	8/21/2004	SWS
438	592	8/21/2004	SWS
438	595	8/21/2004	SWS
438	637	8/21/2004	SWS
438	675	8/21/2004	SWS
438	766	8/21/2004	SWS
438	770	8/21/2004	SWS

SWS

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Key Words: Ion Implantation - Tilt, Sidewall; Thermal Oxidation; Rapid Thermal Process;	8/21/2004	SWS
Self-Aligned Contact (SAC); Plug; Contact Opening, Contact Hole, Conductive Via; Gate, Source, Drain.	8/21/2004	SWS
Search Tools - EAST (attached): USPAT; US PG PUBS; Derwent; EPO; JPO; IBM TDB	8/21/2004	SWS